



INFORMATION DISCLOSURE STATEMENT

Case Name: Hodes 7-13-19-21-14-10-5
 Serial No. 10/803565
 Applicant: Hodes et al.
 Filing Date: March 18, 2004
 Group: 1795

U.S. PATENT DOCUMENTS

*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date
AA	6,185,961	2/13/2001	Tonucci, et al.	65	60.4	1/27/1999
AB	US Pat. App. 10/799964		Amey, et al.			9/11/2004
AC	US Pat. App. 10/809549		Amey, et al.			3/23/2004
AD	US Pat. App. 10/816569		Gasperian, et al.			4/1/2004
AE	US Pat. App. 10/674440		Hodes, et al.			9/30/2003
AF	US Pat. App. 10/803565		Hodes, et al.			3/18/2004
AG	US Pat. App. 10/802641		Hodes, et al.			3/18/2004
AH	US Pat. App. 10/480459		Kornblit, et al.			3/31/2003
AI	US Pat. App. 10/840385		Kornblit, et al.			8/27/2003
AJ	US Pat. App. 10/716084		Kroupenkin, et al.			11/18/2003
AK	US Pat. App. 10/809579		Kroupenkin, et al.			3/18/2004
AL	US Pat. App. 10/616774		Kroupenkin, et al.			3/26/2004

FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Subclass	Translation

OTHER (including Author, Title, Date, Pertinent Pages, etc.)

AM	Kim, et al., "Nanostructured Surfaces for Dramatic Reduction of Flow Resistance in Droplet-Based Microfluidics," IEEE, pp. 479-482 (2002). (no month)

***References listed beyond AZ would list as AA-1, AB-2, AC-3 thru AZ-26.

***Note First Page ONLY Header/Footer. Subsequent pages must ONLY have page # layout as header

EXAMINER	/John Maples/	DATE CONSIDERED	04/11/2008
----------	---------------	-----------------	------------

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /J.M./